

Notice of References Cited	Application/Control No. 10/506,814		Applicant(s)/Patent Under Reexamination LEWIS ET AL.	
	Examiner BLESSING M. FUBARA		Art Unit 1618	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,440,743	08-2002	Kabanov et al.	435/458
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
*	N	WO 98/22517	05-1998	WO	STORCh et al.	---
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Bronich et al., "Effects of Block Length and Structure of Surfactant on Self-Assembly and Solution Behavior of Block Complexes," in Langmuir, 2000, Vol. 16, 481-489).
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.